

Message Text

LIMITED OFFICIAL USE

PAGE 01 STATE 184468
ORIGIN EA-12

INFO OCT-01 ISO-00 ONY-00 /013 R

DRAFTED BY EA:EHEGINBOTHAM:CSA
APPROVED BY EA-MR. HEGINBOTHAM
EA/K-MR. SHINN
EA/J-MR. COCHRAN
DESIRED DISTRIBUTION
EA ONLY

-----129855 210100Z /14
O 210040Z JUL 78
FM SECSTATE WASHDC
TO AMEMBASSY TOKYO IMMEDIATE

LIMITED OFFICIAL USE STATE 184468

E.O. 11652: NA

TAGS: ETRD, BTRA, BEXP, JA

SUBJECT: SEMICONDUCTOR INDUSTRY ASSOCIATION: LATEST
DEVELOPMENTS

1. SIA EXECUTIVE DIRECTOR TOM HINKLEMAN PHONED DAS HEGIN-
BOTHAM JULY 18 TO ADVISE THAT SIA HAS TERMINATED SERVICES
OF JOHN VAN SAUN, AND TO REQUEST APPOINTMENT WITH HEGIN-
BOTHAM TUESDAY, JULY 25.

2. SIA FIRST AIM AT THIS POINT IS TO OBTAIN CLARIFICATION
OF EXACT STATE OF PLAY IN ITC AND TSG EFFORTS, WITH ALL
USG AGENCIES CONCERNED, IN AFTERMATH JVS ACTIVITIES, AND
THEN TO REASSESS HOW TO PROCEED. OUR INCLINATION IS TO
SUGGEST THAT AFTER COMPLETING THIS CLARIFICATION PROCESS,
THEY CONSIDER A 2- OR 3-MAN INDUSTRY MISSION TO TOKYO TO
RESEARCH NATURE AND SCOPE OF TRADE BARRIERS WHICH RESIDENT
LIMITED OFFICIAL USE

LIMITED OFFICIAL USE

PAGE 02 STATE 184468

U.S. INDUSTRY REPRESENTATIVES BELIEVE ARE SIGNIFICANT IN
JAPAN. BASED ON THAT SURVEY OF POSSIBLY TWO WEEKS,

AND DISCUSSIONS WITH EMBASSY, INDUSTRY WOULD BE IN A POSI-
TION TO CONSIDER WHETHER FORMAL TSG OR SOME OTHER APPROACH
IS APPROPRIATE TO CIRCUMSTANCES THEY IDENTIFY. THIS FACT-

FINDING MISSION PRIOR TO PROGRAM DECISION IS IN FACT WHAT
WE ORIGINALLY SUGGESTED TO SIA.

3. WOULD APPRECIATE EMBASSY ASSESSMENT OF HOW, IN ITS
BEST JUDGEMENT, INDUSTRY MIGHT BEST PROCEED AT TOKYO END,
IF POSSIBLE BY COB JULY 24. VANCE

LIMITED OFFICIAL USE

NNN

Message Attributes

Automatic Decaptioning: Z
Capture Date: 01 jan 1994
Channel Indicators: n/a
Current Classification: UNCLASSIFIED
Concepts: INDUSTRY, SEMICONDUCTOR DEVICES
Control Number: n/a
Copy: SINGLE
Draft Date: 21 jul 1978
Decaption Date: 20 Mar 2014
Decaption Note: 25 YEAR REVIEW
Disposition Action: RELEASED
Disposition Approved on Date:
Disposition Case Number: n/a
Disposition Comment: 25 YEAR REVIEW
Disposition Date: 20 Mar 2014
Disposition Event:
Disposition History: n/a
Disposition Reason:
Disposition Remarks:
Document Number: 1978STATE184468
Document Source: CORE
Document Unique ID: 00
Drafter: EHEGINBOTHAM:CSA
Enclosure: n/a
Executive Order: N/A
Errors: N/A
Expiration:
Film Number: D780299-0263
Format: TEL
From: STATE
Handling Restrictions:
Image Path:
ISecure: 1
Legacy Key: link1978/newtext/t19780733/aaaabboz.tel
Line Count: 68
Litigation Code IDs:
Litigation Codes:
Litigation History:
Locator: TEXT ON-LINE, ON MICROFILM
Message ID: 8ae1146f-c288-dd11-92da-001cc4696bcc
Office: ORIGIN EA
Original Classification: LIMITED OFFICIAL USE
Original Handling Restrictions: ONLY
Original Previous Classification: n/a
Original Previous Handling Restrictions: n/a
Page Count: 2
Previous Channel Indicators: n/a
Previous Classification: LIMITED OFFICIAL USE
Previous Handling Restrictions: ONLY
Reference: n/a
Retention: 0
Review Action: RELEASED, APPROVED
Review Content Flags:
Review Date: 05 may 2005
Review Event:
Review Exemptions: n/a
Review Media Identifier:
Review Release Date: N/A
Review Release Event: n/a
Review Transfer Date:
Review Withdrawn Fields: n/a
SAS ID: 1925204
Secure: OPEN
Status: NATIVE
Subject: SEMICONDUCTOR INDUSTRY ASSOCIATION: LATEST DEVELOPMENTS
TAGS: ETRD, BTRA, BEXP, ELEC, JA
To: TOKYO
Type: TE
vdkgvwkey: odb://SAS/SAS.dbo.SAS_Docs/8ae1146f-c288-dd11-92da-001cc4696bcc
Review Markings:
Sheryl P. Walter
Declassified/Released
US Department of State
EO Systematic Review
20 Mar 2014
Markings: Sheryl P. Walter Declassified/Released US Department of State EO Systematic Review 20 Mar 2014